

S/N 09/945,553

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Fernando Gonzalez et al.

Examiner: George Fourson

Serial No.: 09/945,553

Group Art Unit: 2823

Filed: August 30, 2001

Docket No.: 303.775US1

Customer No.: 73115

Confirmation No.: 1842

Title: METHOD TO CHEMICALLY REMOVE METAL IMPURITIES FROM
POLYCIIDE GATE SIDEWALLS

COMMUNICATION RE: FEE ADDRESS

Mail Stop Issue Fee
Commissioner for Patents
P.O.Box 1450
Alexandria, VA 22313-1450

In response to the Notice of Allowance and Issue Fee Due, please record the Fee Address under the provisions of 37 CFR 1.363 as the following:

Customer Number 26809

which is associated with Micron Technology, Inc..

Please direct any inquiries to the undersigned attorney at (612) 349-9587.

Respectfully submitted,

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Date

8 Feb '08

By

Timothy B. Clise
Reg. No. 40,957

TBC/cmb

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 8 day of February, 2008.

Name

CHRIS BAKER

Signature

CBaker